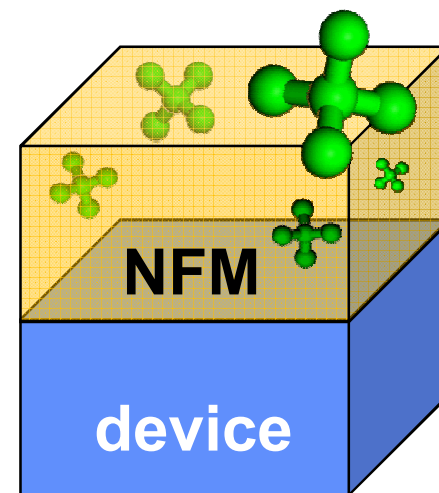
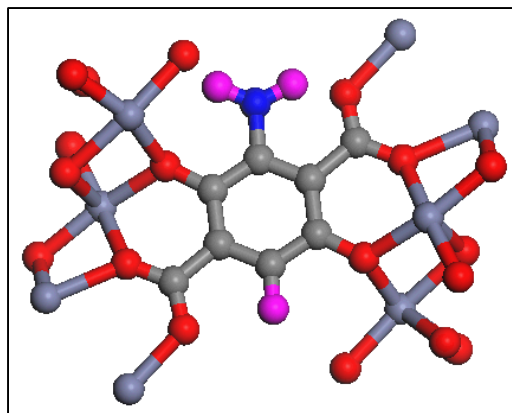
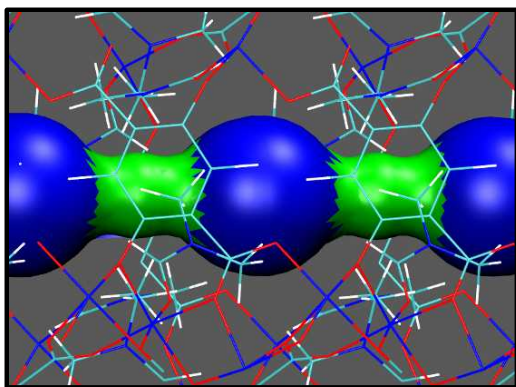


Computational Modeling of Low-Pressure Gas Detection in Nanoporous Framework Materials



27 April, 2011 4:15 pm

Todd R. Zeitler¹, Mark D. Allendorf² and Jeffery A. Greathouse¹

¹Sandia National Laboratories, Albuquerque, New Mexico, ²Sandia National Laboratories, Livermore, California



Can NFMs be used to detect methane?

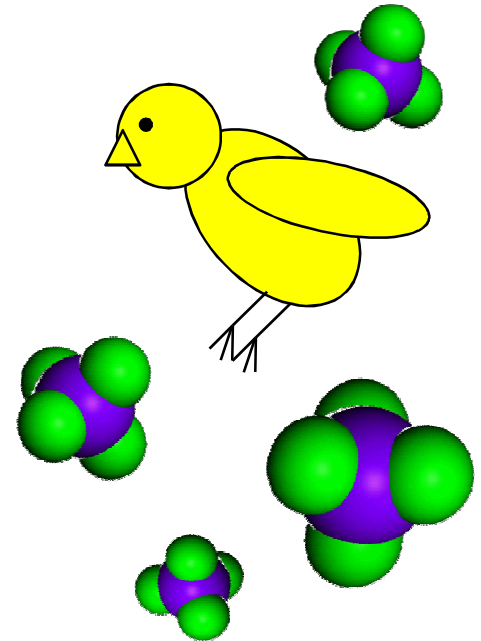
5-15 % CH₄ is explosive

Environmental impact

Greenhouse gas accumulation

Landfill leakage

Main constituent of natural gas

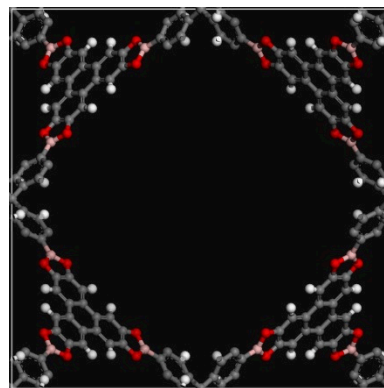


There are 20,000+ NFMs in literature

**Which NFMs are
good for low-level
gas uptake?**

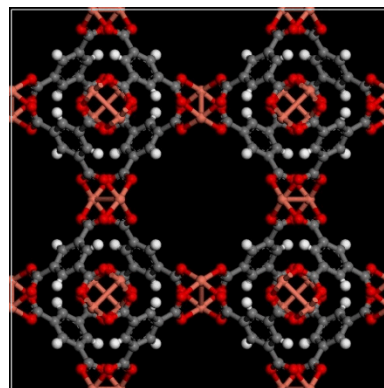
**Which NFM
properties are
useful?**

COF-108



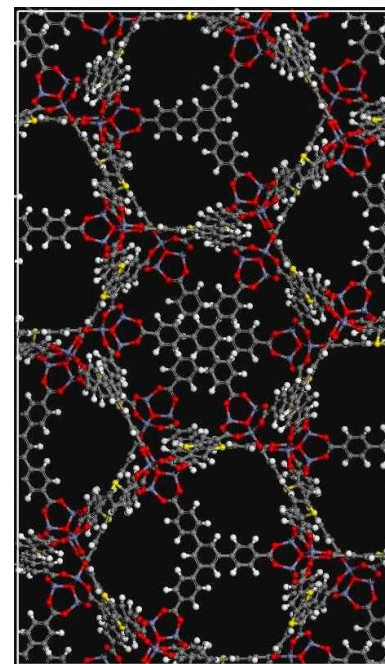
$\rho: 0.17 \text{ g/cm}^3$

Cu-BTC



open metal sites / small cages

UMCM-2



$5000+ \text{ m}^2/\text{g}$

GCMC simulation is a quick screening tool

Insertion/deletion

Loading vs. pressure

Henry's constant (k_H)

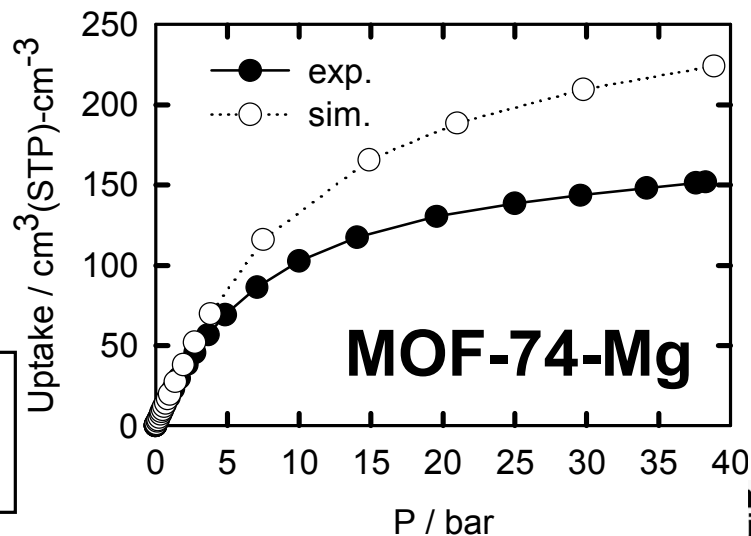
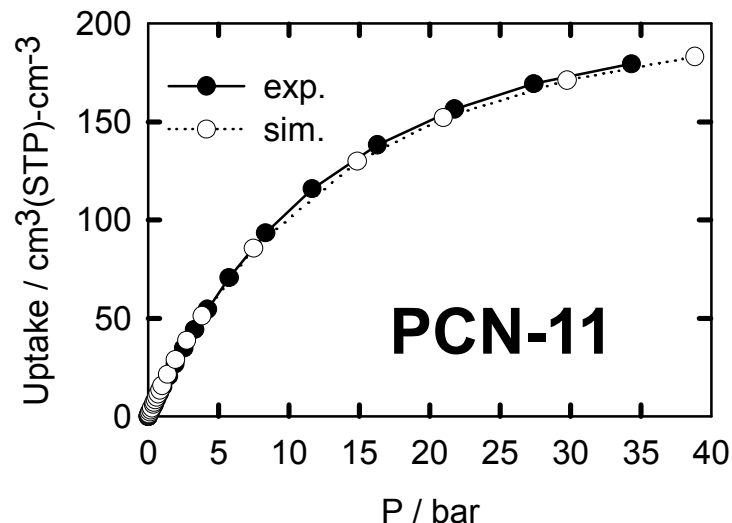
Initial heat of
adsorption (Q_{st})

Large no. of
structures quickly

UFF parameters

298 K

Rigid model of NFM 1-site CH_4 model



Which NFM features enhance low-P uptake?

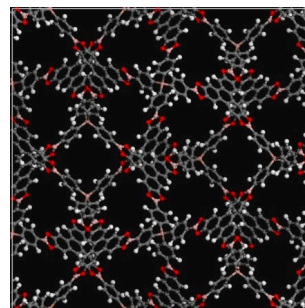
Surface area

Pore diameter

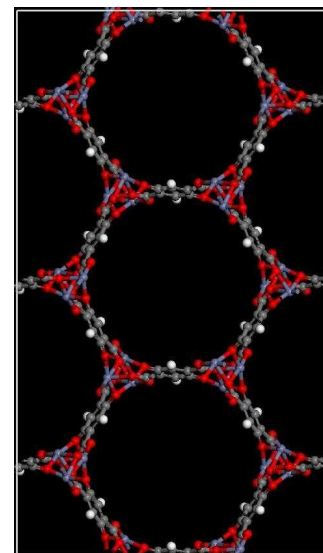
Free volume

Open metal sites

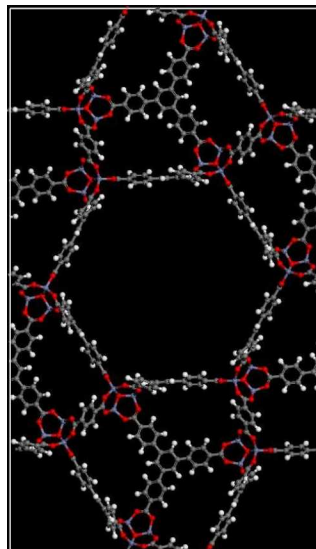
COF



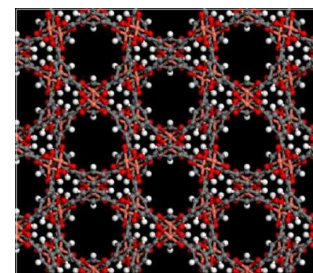
MOF-74-M



UMCM

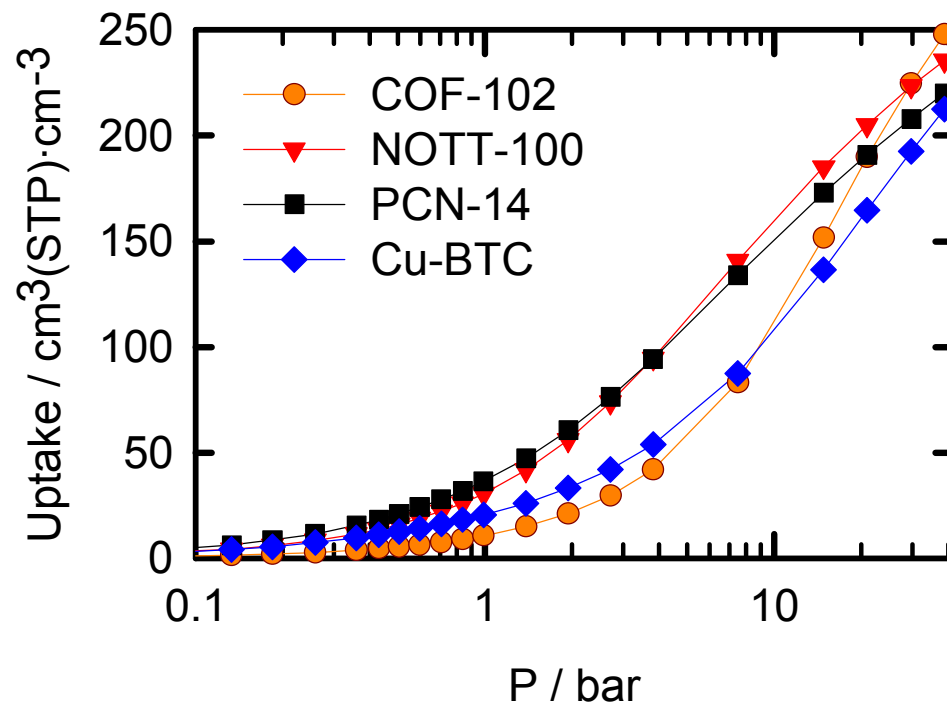


Cu-based



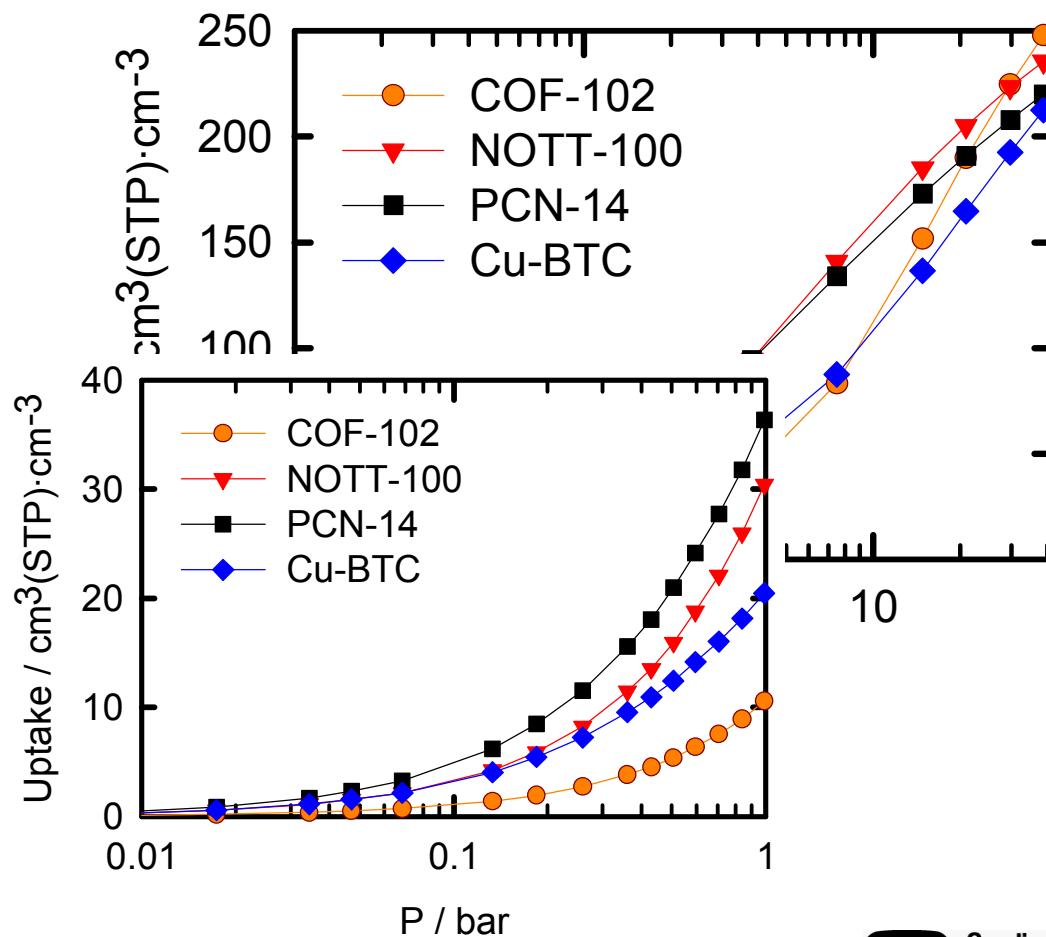
Relative uptake is pressure dependent

**NFMs good for
high-P CH_4
storage
applications
not necessarily
good at low-P**

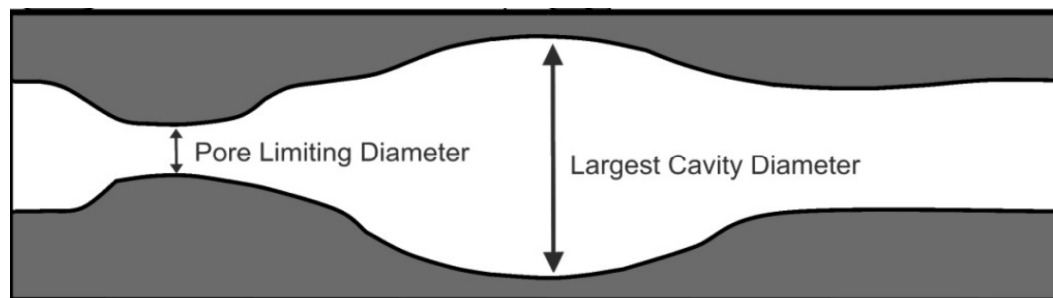
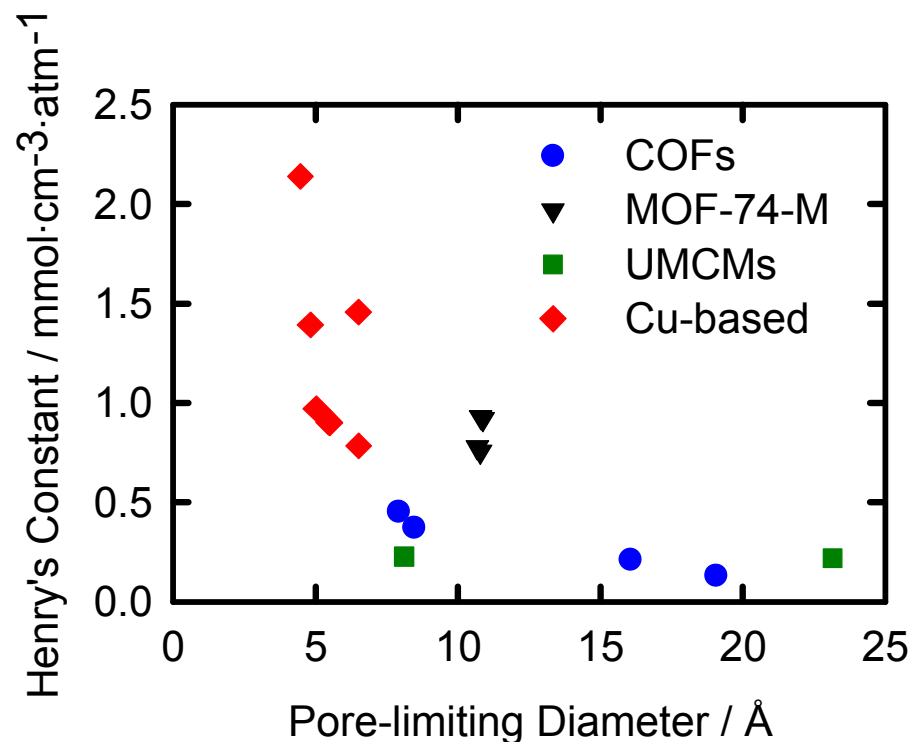
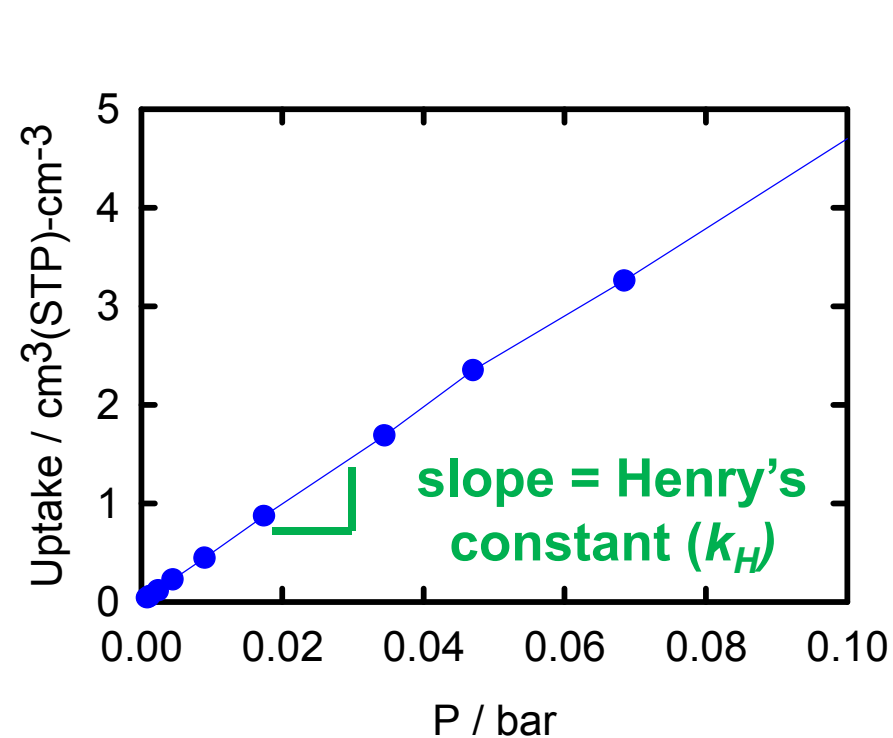


Relative uptake is pressure dependent

**NFMs good for
high-P CH_4
storage
applications
not necessarily
good at low-P**



Pore diameter is correlated to initial uptake



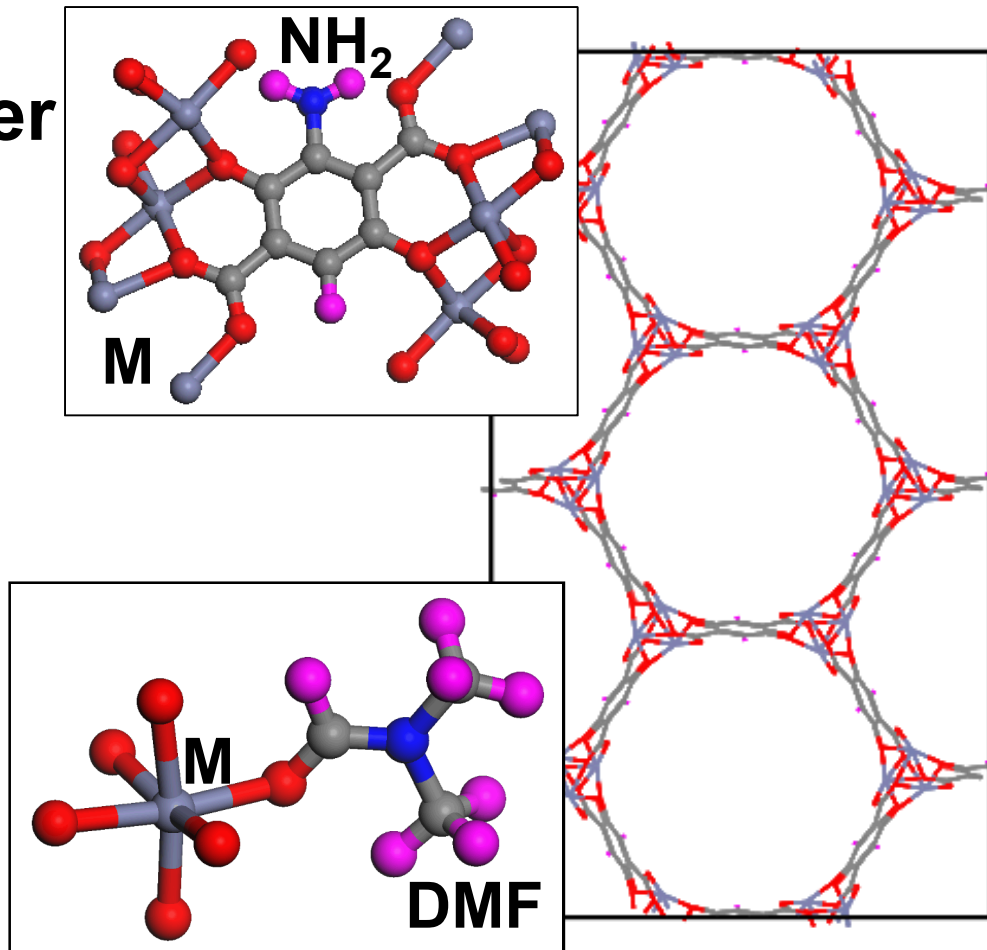
Can functionalization enhance uptake?

Amine (NH_2) on linker

Dimethylformamide
(DMF) on metal

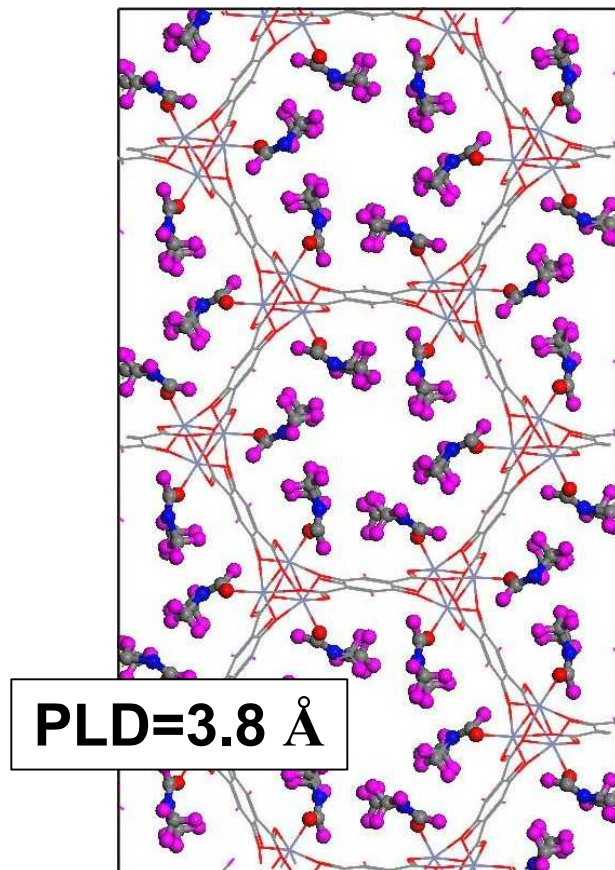
MOF-74-M

M = Zn, Ni, Co, Mg



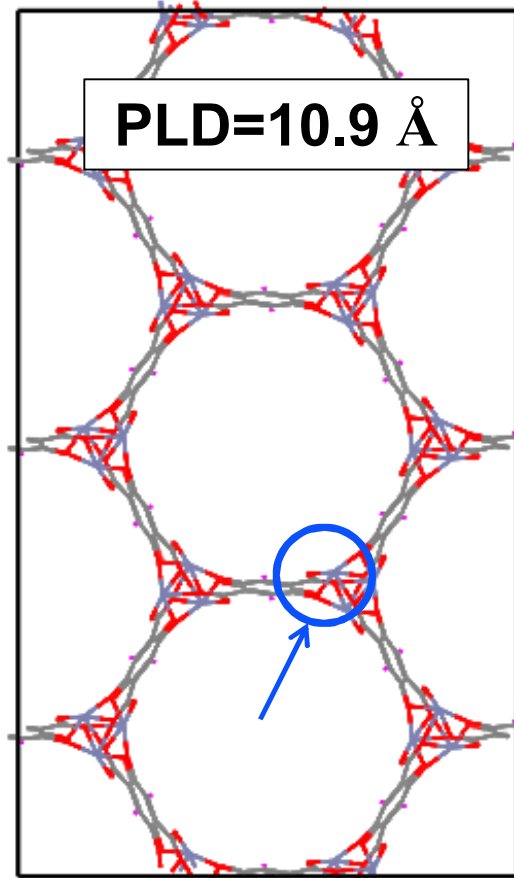
Functionalization changes pore size

MOF-74-Zn-DMF



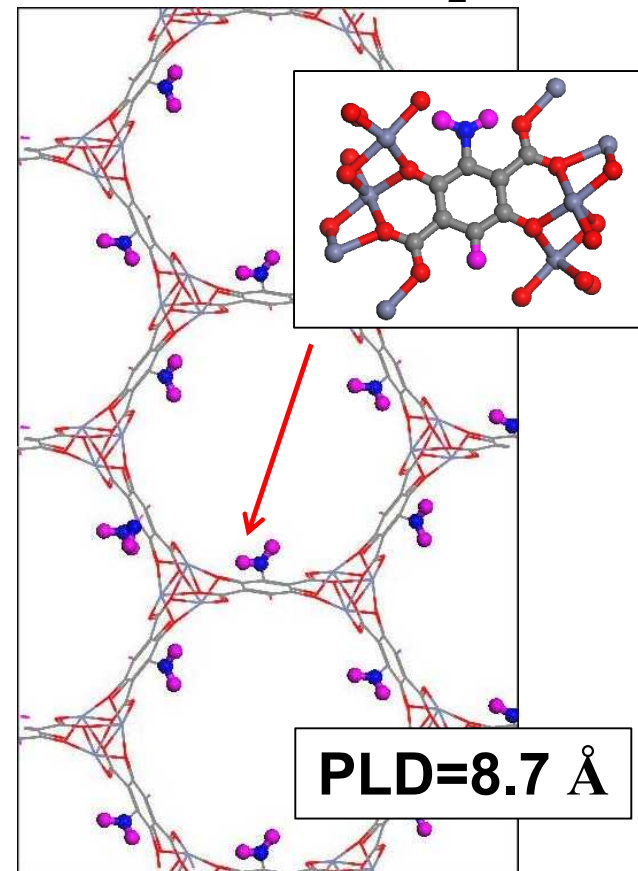
MOF w/DMF solvent
intact
(no open metal sites)

MOF-74-Zn



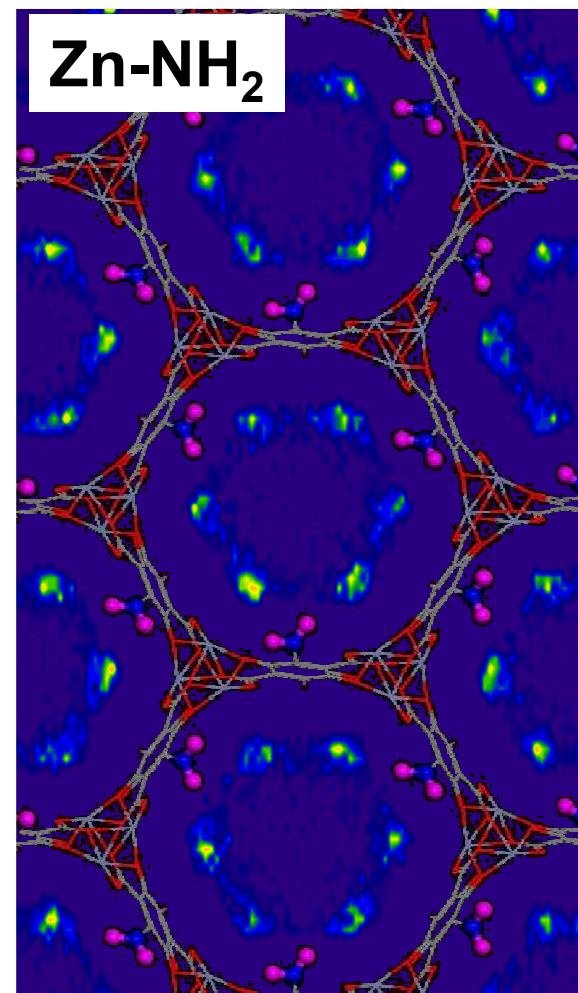
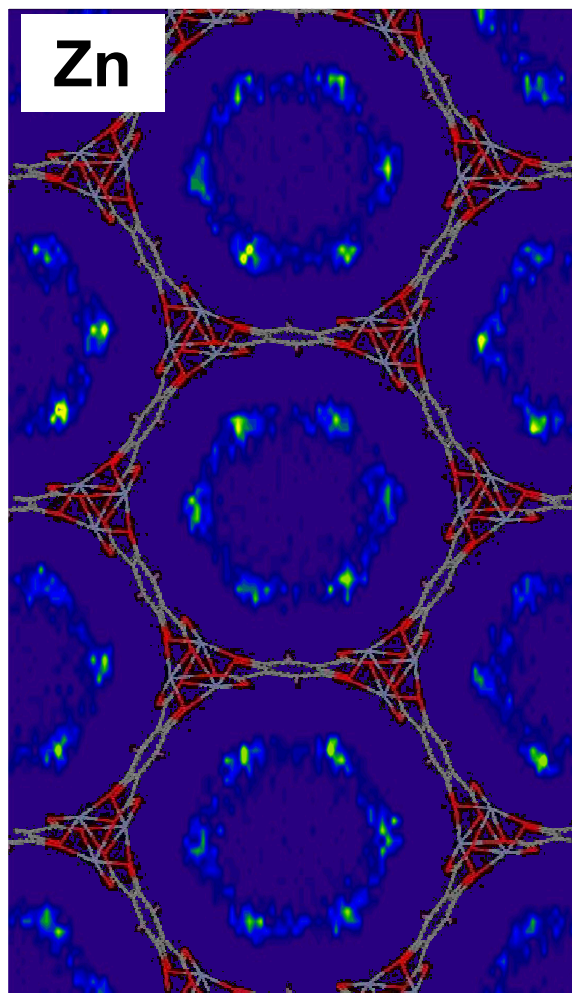
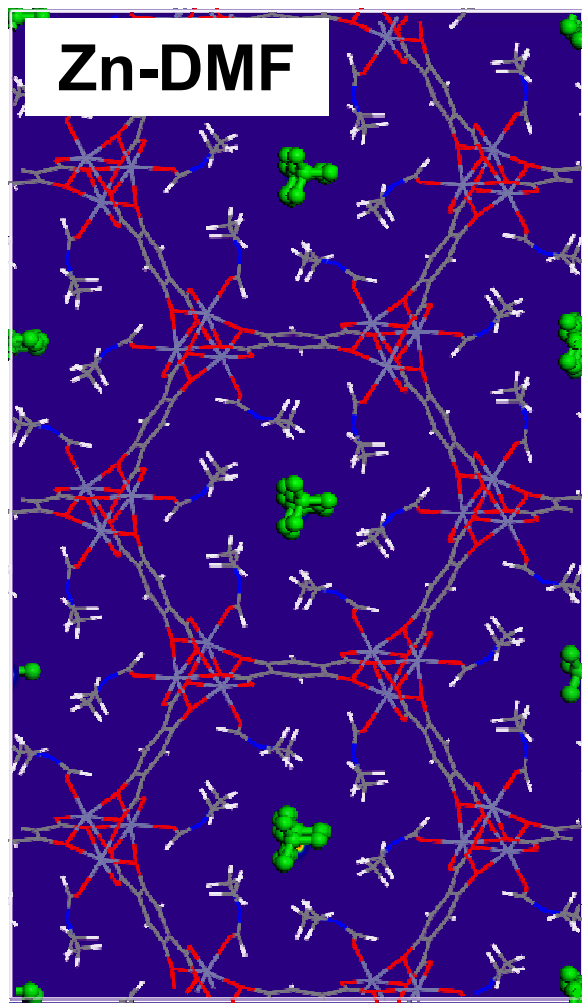
solvent removed
(open metal sites
exposed)

MOF-74-Zn-NH₂

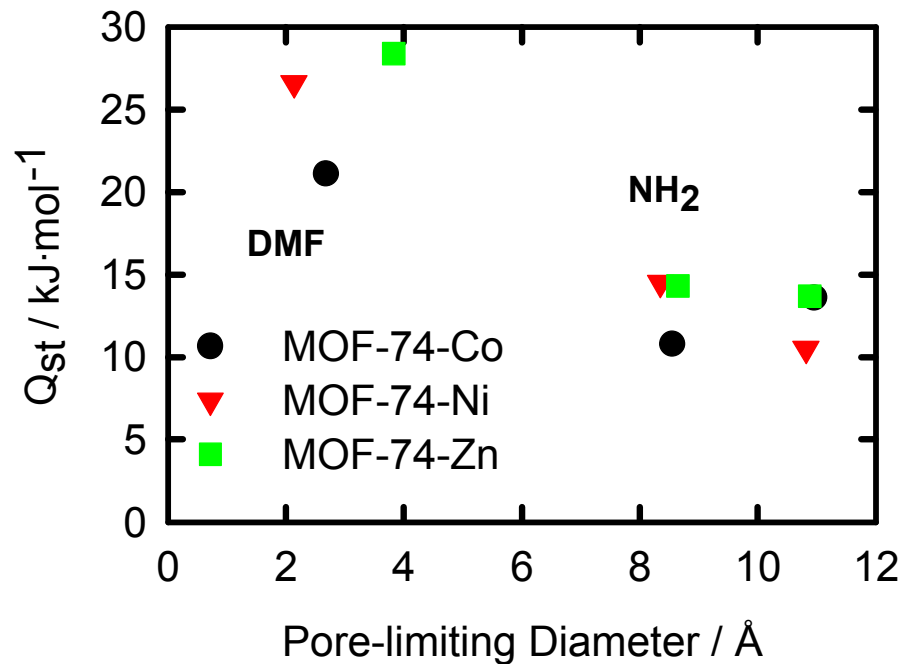
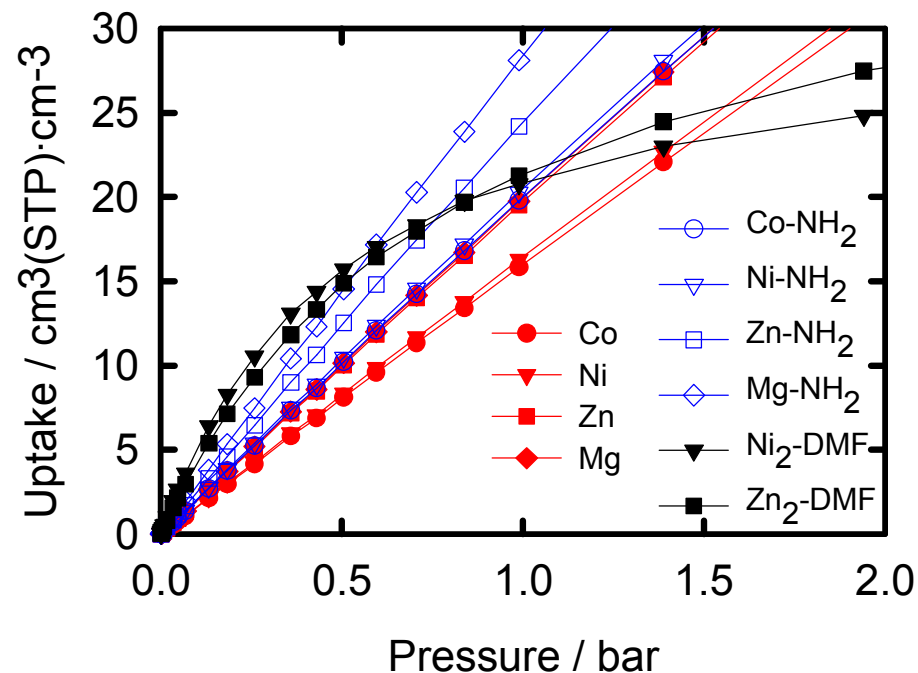


NH₂ added

Functionalization influences uptake sites

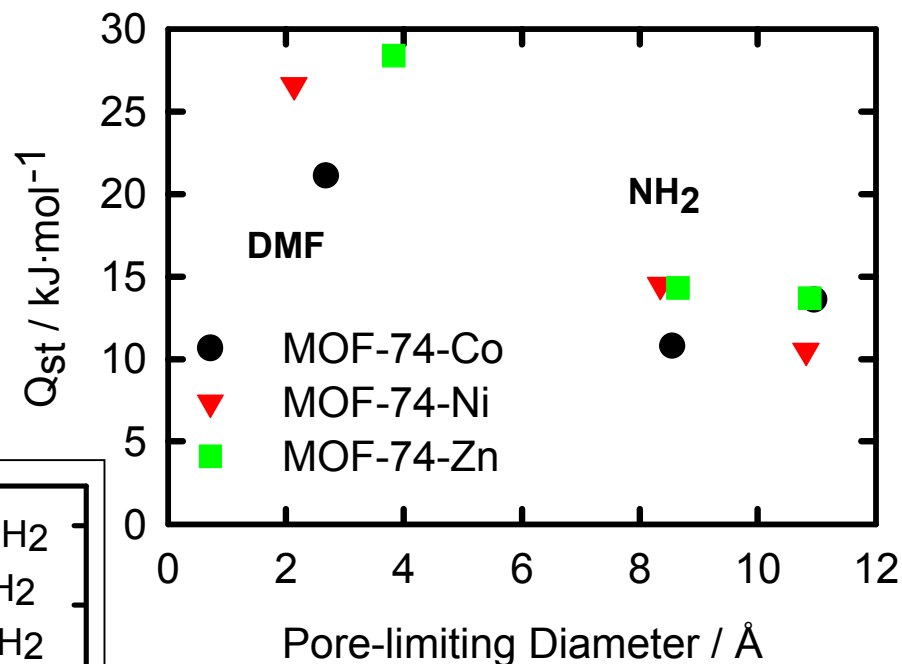
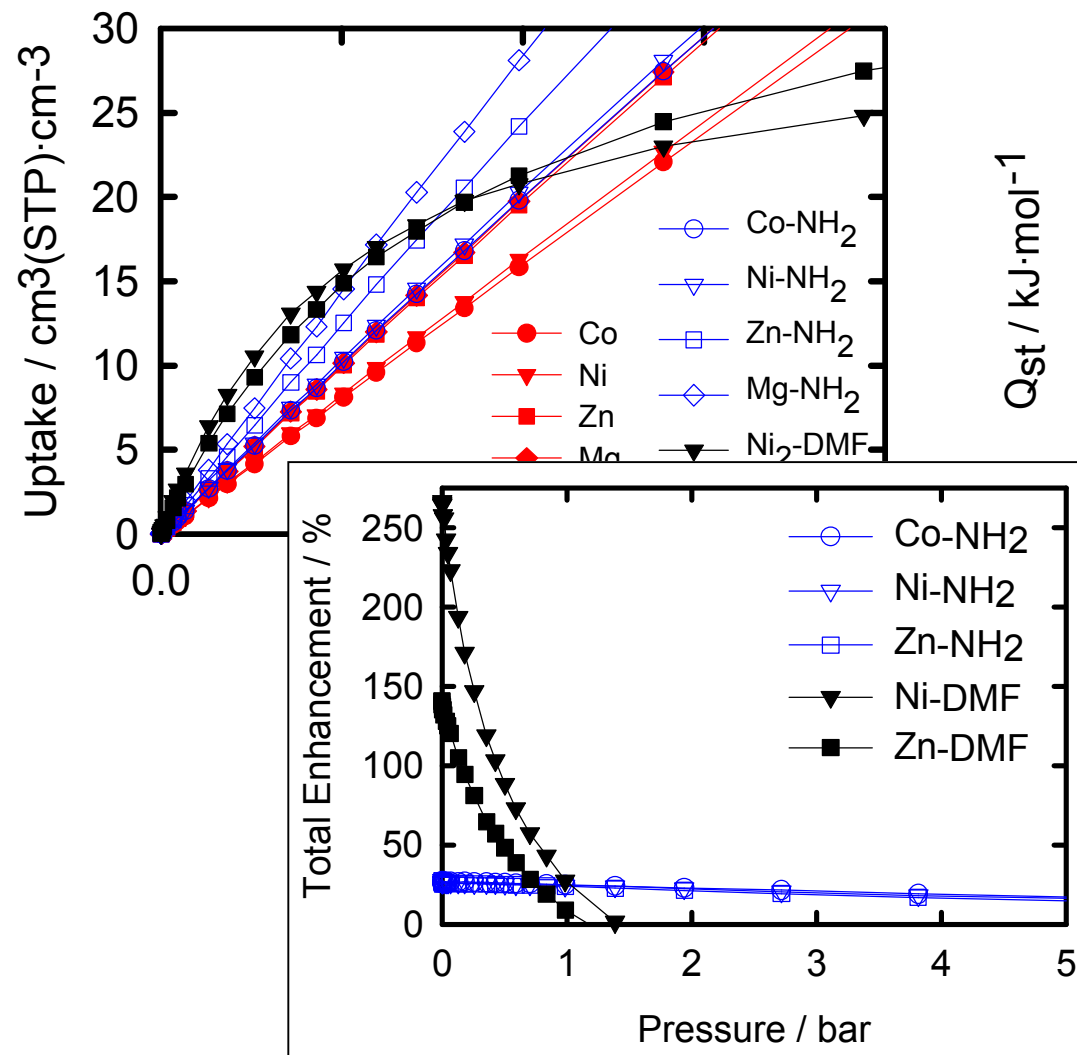


Functionalization enhances low-P uptake



Reduction in pore diameter leads to enhanced uptake.

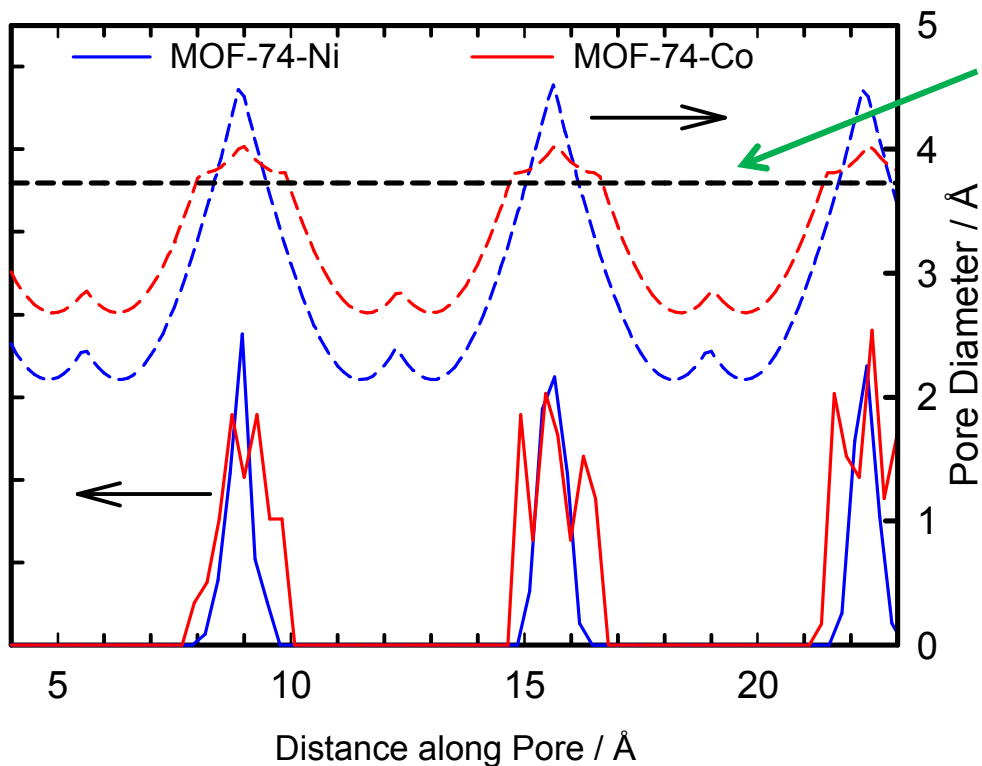
Functionalization enhances low-P uptake



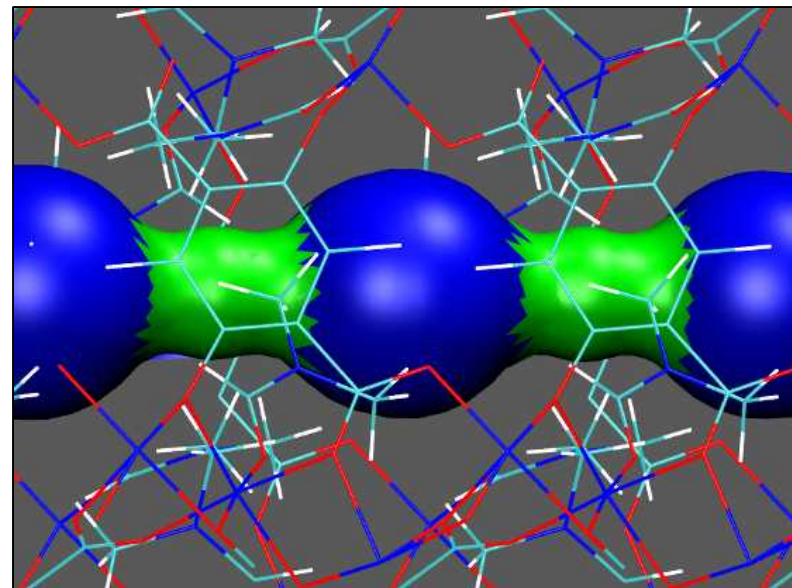
Reduction in pore diameter leads to enhanced uptake.

Pore diameter defines adsorption sites

Relative CH₄ Concentration / arbitrary unit

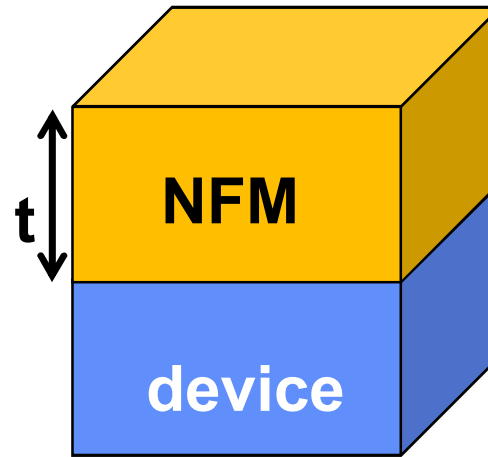
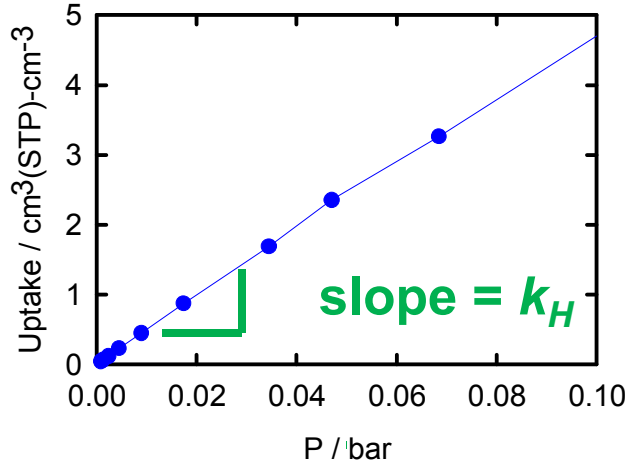


Adsorption only takes place where pore diameter exceeds CH₄ diameter.



pore mapped along <001>

Adsorption results are relevant to detection



$$t = \frac{L_s}{2440 * \rho_{gas,STP} * k_H * P_{gas}}$$

t : minimum NFM thickness (nm)

L_s : sensing limit (ng/cm²)

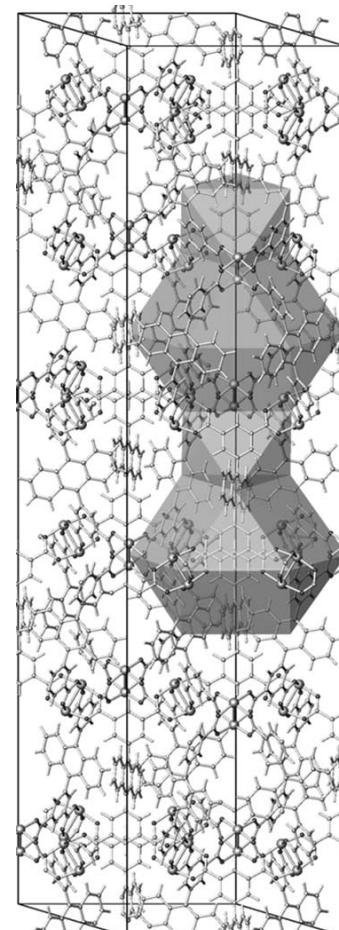
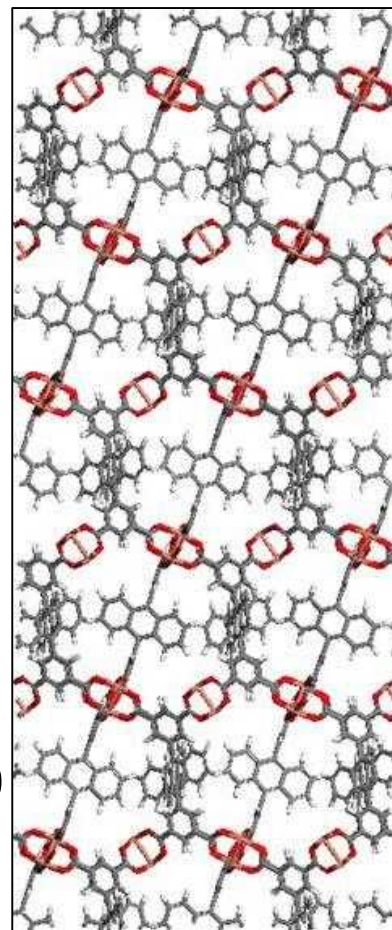
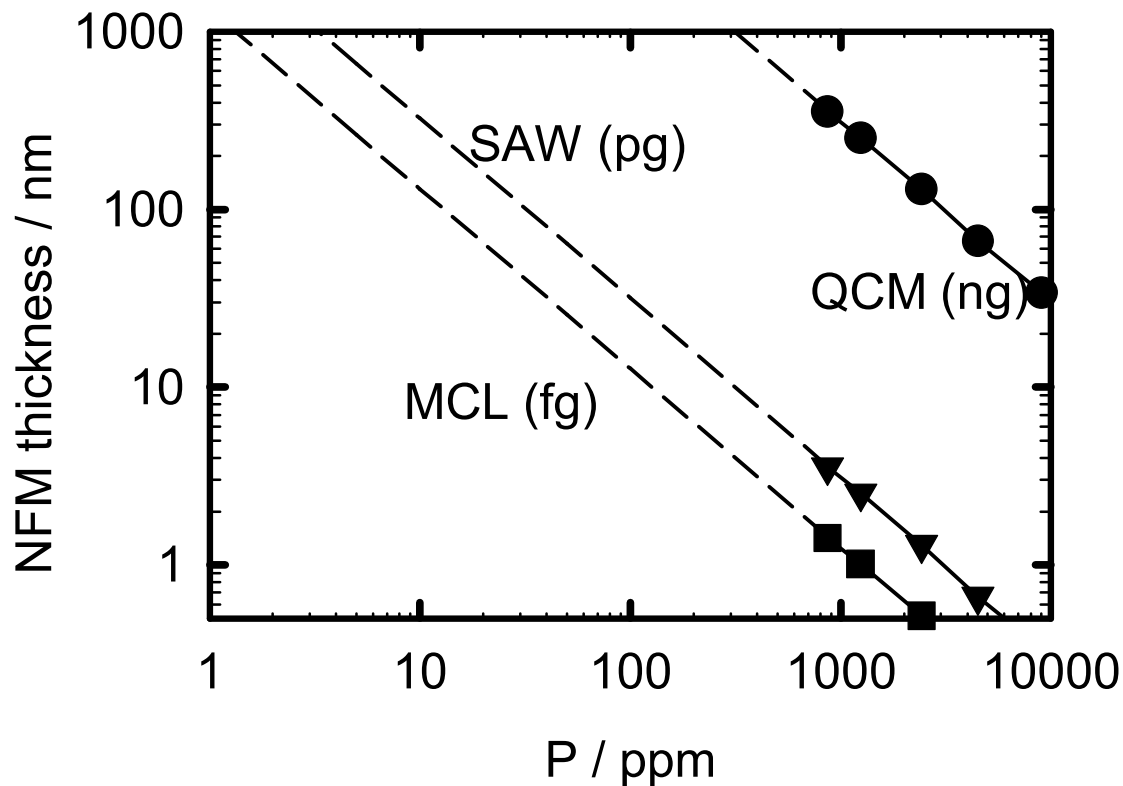
$\rho_{gas,STP}$: gas density @ STP (g/cm³)

k_H : Henry's constant (v(STP)/v·bar)

P_{gas} : partial pressure of analyte (bar)

Sensor Type	Sensing Area (cm²)	Minimum Detectable Mass	Sensing Limit, L_s (ng/cm²)	Relative Sensitivity
QCM	1.0	1 ng	1.0	1
SAW	0.10	1 pg	0.01	100
15 MCL	0.00025	1 fg	0.004	250

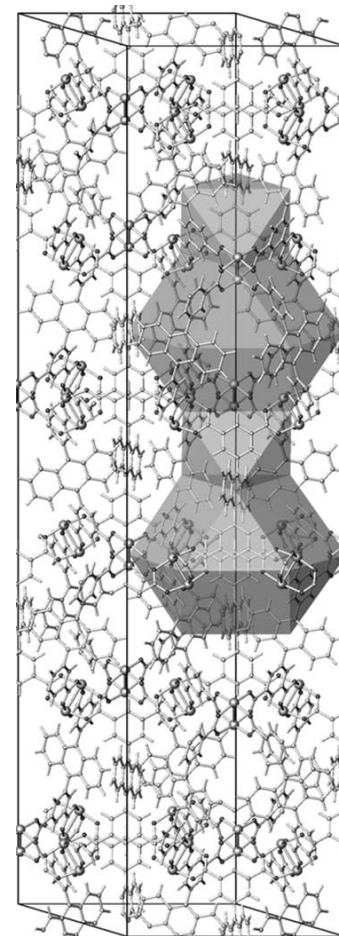
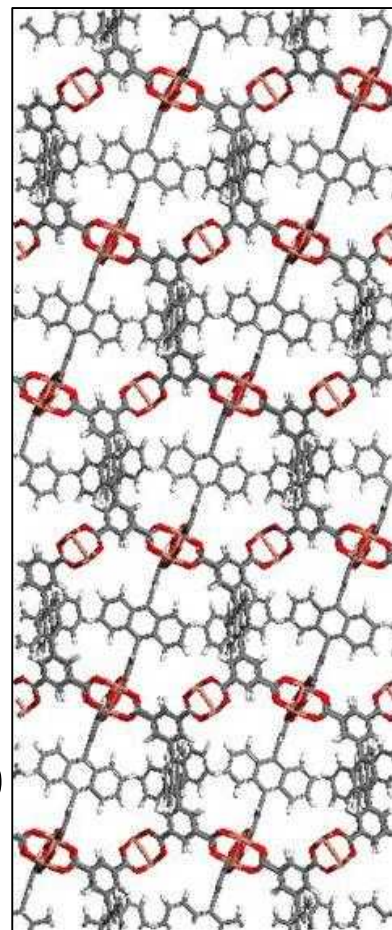
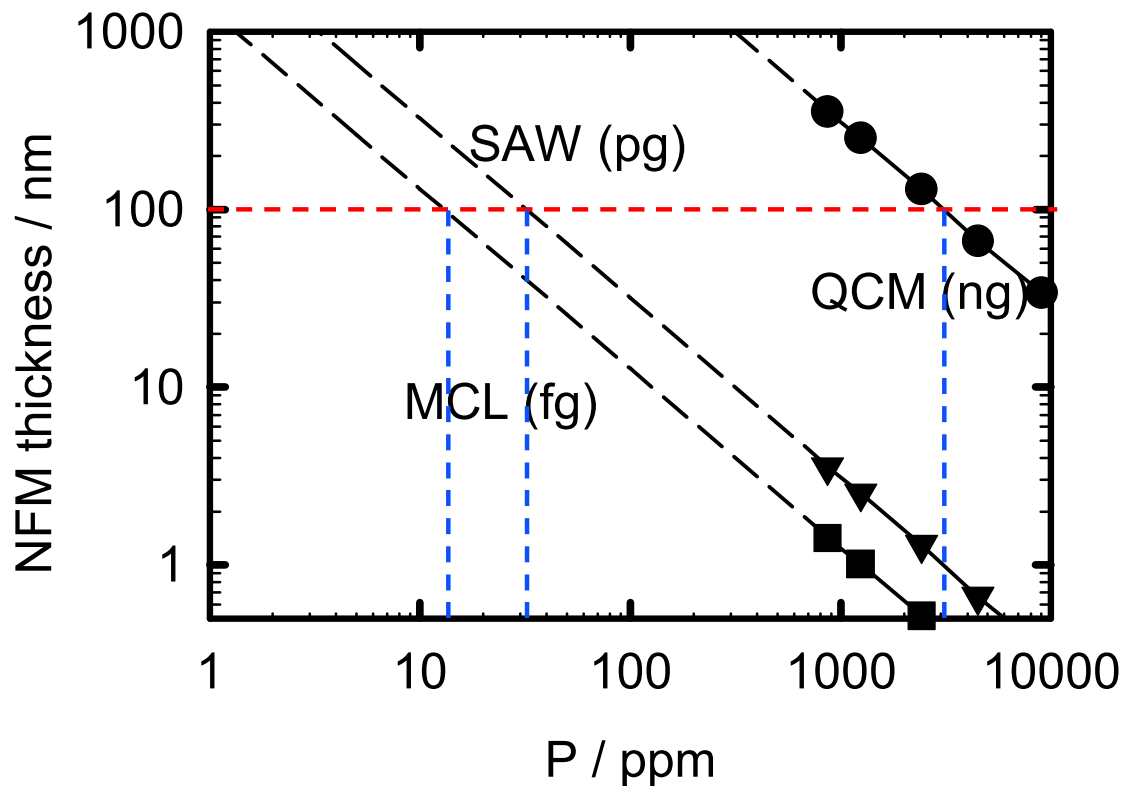
Minimum NFM thickness for detection limit



PCN-14 has highest k_H of NFMs in this study

Wu, et al. Chem.-Eur. J. 2010, **16**, 5205-5214.

Minimum NFM thickness for detection limit



PCN-14 has highest k_H of NFMs in this study

Wu, et al. Chem.-Eur. J. 2010, **16**, 5205-5214.

Conclusions

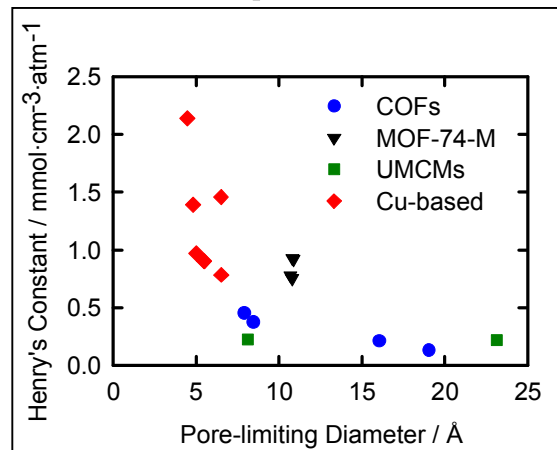
NFMs for low-level CH₄ uptake should have small pores.

PLD ~ diameter of CH₄ molecule

Functionalization can enhance uptake.

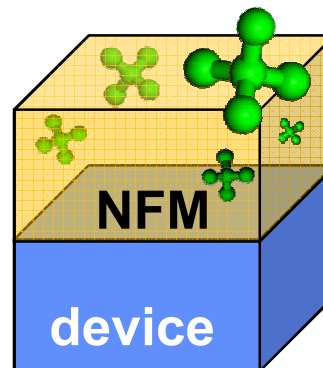
Linker—NH₂ ~ 25 %

Pore solvent—DMF 100-250 %



Hypothetical minimum NFM layer thickness for sensing devices

$$t = \frac{L_s}{2440 * \rho_{gas,STP} * k_H * P_{gas}}$$



Conclusions

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